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U.S. UTILITY Patent Application

PATENT NUMBER and  
ISSUE DATE

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10034366	01/03/2002	430	322	1756	David A. Chao & David

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**\*\*CONTINUING DATA VERIFIED:**

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**\*\* FOREIGN APPLICATIONS VERIFIED:**  
JAPAN 2001-112174 11/04/2001

PG-PUB ☐ DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed ☐ yes ☐ no  
35 USC 119 conditions met ☐ yes ☐ no  
Verified and Acknowledged Examiners's initials

ATTORNEY DOCKET NO  
740189-717

TITLE : Pattern formation material and pattern formation method

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)

<b>NOTICE OF ALLOWANCE MAILED</b>		<b>CLAIMS ALLOWED</b>	
		Assistant Examiner	
<b>ISSUE FEE</b>		Total Claims	
Amount Due	Date Paid	Print Claim for O.G.	
		<b>DRAWING</b>	
		Sheets Drwg. Figs. Drwg. Print Fig.	
		Primary Examiner	
		Application Examiner	
<input type="checkbox"/> <b>TERMINAL DISCLAIMER</b>		<b>PREPARED FOR ISSUE</b>	
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